

<b>Notice of References Cited</b>	Application/Control No. 10/600,340	Applicant(s)/Patent Under Reexamination OU, CHI-YUAN	
	Examiner Jeff Piziali	Art Unit 2673	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0145580 A1	07-2004	Perlman, Stephen G.	345/204
	B	US-2004/0090533 A1	05-2004	Dow et al.	348/220.1
	C	US-2004/0069117 A1	04-2004	Akins, Randy D.	084/486
	D	US-2004/0012620 A1	01-2004	Buhler et al.	345/716
	E	US-2003/0109286 A1	06-2003	Hack et al.	455/566
	F	US-2002/0167500 A1	11-2002	Gelbman, Alexander	345/204
	G	US-2002/0030638 A1	03-2002	Weiner, Michael	345/30
	H	US-2002/0000984 A1	01-2002	Asai et al.	345/211
	I	US-6,766,332 B2	07-2004	Miyazaki et al.	707/102
	J	US-6,504,580 B1	01-2003	Thompson et al.	348/734
	K	US-6,442,573 B1	08-2002	Schiller et al.	715/500.1
	L	US-6,069,848 A	05-2000	McDonald et al.	368/107
	M	US-5,931,764 A	08-1999	Freeman et al.	482/4

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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